



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812  
Examiner: Not yet assigned  
Confirmation No.: 4501

In re PATENT APPLICATION of:

Applicant(s): Osamu KATO

Serial No.: 10/689,032

Filed: October 21, 2003

For: METHOD FOR FABRICATING A GATE  
MASK OF A SEMICONDUCTOR DEVICE

Docket No.: FUJI 138

)  
)  
)  
)  
) **SUBMISSION OF**  
) **FORMAL DRAWINGS**  
)  
)  
)

\_\_\_\_\_  
April 13, 2004

**MAIL STOP PGPUB DRAWINGS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby submits seven (7) replacement sheets of Formal Drawings  
(Figs. 1A-5).

Respectfully submitted,

Robert H. Berdo, Jr.  
Registration No. 38,075  
RABIN & BERDO, PC  
Customer No. 23995  
Telephone: 202-371-8976  
Facsimile: 202-408-0924

April 13, 2004  
Date

RHB:crh

**FREE ENCLOSED:**  
Please charge any further  
fee to our Deposit Account  
No. 18-0002